



SPW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q80781

Takeyoshi KANO, et al.

Appln. No.: 10/828,472

Group Art Unit: 1774

Confirmation No.: 5352

Examiner: Tamra Dicus

Filed: April 21, 2004

For: PATTERN FORMING METHOD, IMAGE FORMING METHOD, FINE PARTICLE ADSORPTION PATTERN FORMING METHOD, CONDUCTIVE PATTERN FORMING METHOD, PATTERN FORMING MATERIAL AND PLANOGRAPHIC PRINTING PLATE

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This responds to the Restriction Requirement, dated October 10, 2006, being timely filed on November 13, 2006, as November 10, 2006, was a Federal holiday.

In response to the Restriction Requirement, Applicant elects Group I, claims 1-9, for examination. This election is made without traverse.

Applicant reserves the right to file a Divisional Application directed to non-elected claims 10-19.

The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any

RESPONSE TO RESTRICTION REQUIREMENT
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overpayments to said Deposit Account.

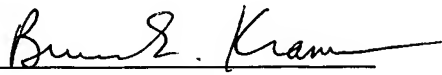
Respectfully submitted,

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WASHINGTON OFFICE

23373

CUSTOMER NUMBER


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Date: November 13, 2006